



#2/4-402
2812

P/1071-1245

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
Toshiaki OZASA
Serial No.: 09/734,457
Filed: December 11, 2000

New York, New York
Date: March 25, 2002
Group Art Unit: 2812
Examiner: --

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For: CERAMIC ELECTRONIC COMPONENT AND METHOD OF
PRODUCING THE SAME

U.S. Patent & Trademark Office
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Arlington, VA 22202

SUBMISSION

Sir:

Submitted herewith is a copy of a search report issued by a patent searching authority other than the PTO and the cited art together with a form listing the same for the convenience of the Examiner.

I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in a counterpart foreign application not more than 3 months prior to the filing of this Submission.

I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail #EL157419702US in an envelope addressed to: U.S. Patent & Trademark Office, P.O. Box 2327, Arlington, VA 22202, on March 25, 2002:

Dorothy Jenkins

Name of applicant, assignee or
Registered Representative

Dorothy Jenkins

Signature

March 25, 2002

Date of Signature

Respectfully submitted,

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Enclosures



Rejection Notice

Patent Application No.	10-094518	
Date Drafted	January 29, 2002	
Patent Office Examiner	Hiroshi EBATA	7509 5R00
Patent Application Agent	Masaaki KOSHIBA	(and 1 other)
Applicable Provisions	Section 29, Paragraph 2	

This application should be rejected for the following reason. If there are other opinions regarding this decision, please submit an opinion brief within 60 days of the date on which this notice was issued.

Reason

The invention in this application pertaining to the claims mentioned below cannot receive a patent in accordance with Section 29, Paragraph 2 of the Patent Law because the invention in this application can be easily made by a person of ordinary skill in the art for the technical classification to which the invention belongs based on the inventions disclosed in the below-mentioned publications which had been widely available in Japan and overseas prior to this application.

(For Cited Documents Please Refer to the List of Cited Documents)

* Claims: 1~3
* Cited Documents: 1~3
* Comments:

1. For the application of a stress-relieving layer (conductive resin layer) to the second layer of the outer electrode, please refer to Cited Document 1 (Cited Document 1: [Claims] [0009] ~ [0011] [0023] [0026]). For the formation of the stress-relieving layer in the outer electrode layer structure as a porous structure, please refer to Cited Document 2 (Cited Document 2: [Claims] [0006] [0016].) It is easy to render the stress-relieving layer in Cited Document 1 as a porous structure.

2. For a configuration containing conductive particles in the outer electrode layers, please refer to Cited Document 3 (Cited Document 3: [Claims] [0008] [0009]).

3. In Claim 3, the difficulty of applying conductive particles to the porous electrode layers in Cited Document 2 is not clear and the particle diameter is more or less obvious.

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(List of Cited Documents)

1. Unexamined Patent Application Publication (Kokai) No. 08-162359
2. Unexamined Patent Application Publication (Kokai) No. 08-203771
3. Unexamined Patent Application Publication (Kokai) No. 04-311015

At the present time, there are no other reasons for refusal pertaining to the claims of the invention other than those mentioned above. If a new reason for refusal is discovered, notification of the reason for refusal shall be issued.

Record of Search Results from Prior Art Documents

- Classification Searched IPC⁷ H 01 G 4/00 ~ 4/42
- Prior Art Documents

The search results from prior art documents in this classification did not yield any reasons for refusal.

[Received: February 6, 2002. Koshiha International Patent Office]
[Ichibayashi February 8, 2002]

Sub-class	Filing Date IR Appropriate